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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Athavale et al.

Examiner: Deo, Duy Vu Nguyen

Serial No: 09/757,123

Group Art Unit: 1765

Filed: January 9, 2001

Docket: 01 P7408 US 02 (8055-142)

For: **METHOD FOR DRY ETCHING DEEP TRENCHES IN A SUBSTRATE**

Mail Stop: RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA. 33212-1450

AMENDMENT

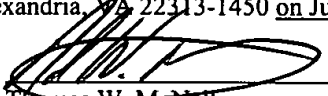
This is a response to the Advisory Action mailed on June 9, 2003, and the Final Office Action mailed on March 25, 2003. A Request for Continued Examination (RCE) has been filed herewith. Please amend the application as follows:

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CERTIFICATE OF MAILING 37 C.F.R. § 1.8(a)

I hereby certify that this correspondence (and any document referred to as being attached or enclosed) is being deposited with the United States Postal Service as first class mail, postage paid in an envelope addressed to: Mail Stop RCE, Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on July 24, 2003.

Dated: 24/7/2003

  
Thomas W. McNally